

032504

18379 U.S. PTO

Sughrue

SUGHRUE MION, PLLC

2100 Pennsylvania Avenue, NW
Washington, DC 20037-3213T 202.293.7060
F 202.293.7860

www.sughrue.com

March 25, 2004

MAIL STOP PATENT APPLICATIONCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-145017538 U.S. PTO
10/808540
032504

Re: Application of Ryu OHTAGURO and Koichi HASHIGUCHI
SUBSTRATE FOR PHOTOMASK, PHOTOMASK BLANK AND PHOTOMASK
Assignee: **HOYA CORPORATION**
Our Ref. Q80708

Dear Sir:

Attached hereto is the application identified above comprising thirty-one (31) sheets of the specification, including the claims and abstract, and three (3) sheets of drawings. **The requisite U.S. Government Filing Fee, copies of the executed Declaration and Power of Attorney and Assignment will be submitted at a later date. Also enclosed is an Information Disclosure Statement and PTO/SB/08 A & B (modified).**

The Government filing fee is calculated as follows:

Total claims	14 - 20	=		x	\$18.00	=	\$0.00
Independent claims	9 - 3	=	6	x	\$86.00	=	\$516.00
Base Fee							\$770.00

TOTAL FEE**\$1286.00**

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2003-84992	March 26, 2003
Japan	2004-73763	March 16, 2004

The priority documents will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By: *Darryl Mexic*
Darryl Mexic
Registration No. 23,063SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860WASHINGTON OFFICE
23373
CUSTOMER NUMBER